

	<b>Hit s</b>	<b>Search Text</b>	<b>DBs</b>
<b>51</b>	8	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (print\$4 near5 roll\$4) and (collector near5 roll) and (transfer near5 (layer or roll\$4)) and (substrate) and ((circumference or length) same (blanket or intaglio or cliché or roll\$4 or transfer))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
<b>52</b>	13	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (print\$4 near5 roll\$4) and (collector near5 roll) and (transfer near5 (layer or roll\$4)) and ((circumference or length) same (blanket or intaglio or cliché or roll\$4 or print\$4 or transfer or layer) same (substrate or wafer))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB

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